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August 7, 2003

ATTORNEY DOCKET NO. 03180.0329
CUSTOMER NO. 22,852

Mail Stop Patent Application

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

00746 U.S. PTO
10/635539
08/07/03



New U.S. Patent Application
Title: APPARATUS AND METHOD FOR EVALUATING
SEMICONDUCTOR MATERIAL

Inventors' Names and Addresses:

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Sir:

We enclose the following papers for filing in the United States Patent and Trademark Office in connection with the above patent application.

1. Application- 58 pages, including 8 independent claims and 19 claims total.

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2. Drawings- 22 sheets of drawings containing 32 Figures (Figures 1-28).
3. Certified copy of Japanese Patent Application No. 2003-100442, filed April 3, 2003.
4. Information Disclosure Statement and Information Disclosure Citation, PTO 1449 with 1 document attached.
5. The filing fee is calculated as follows:

Basic Application Filing Fee				\$750	\$	\$750.00
	Number of Claims	Basic	Extra Claims			
Total Claims	19	-	20	0	x \$18	
Independent Claims	8	-	3	5	x \$84	\$ 420.00
<input type="checkbox"/> Presentation of Multiple Dep. Claim(s)				+\$280		
Subtotal					\$	1170.00
Reduction by 1/2 if small entity					-	
TOTAL APPLICATION FILING FEE					\$	1170.00

6. A check for \$1170.00 is enclosed. The fee includes:

\$750.00 filing fee; and
\$420.00 additional claims fee

This application is being filed under the provisions of 37 C.F.R. § 1.53(f).
Applicants await notification from the Patent and Trademark Office of the time set for
filing the Declaration.

Applicants claim the right to priority based on Japanese Patent Application No.
2003-100442, filed April 3, 2003.

Please address all correspondence with respect to this application to:

Finnegan, Henderson, Farabow,
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1300 I Street, N.W.
Washington, D.C. 20005-3315

Please accord this application a serial number and filing date.

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The Commissioner is hereby authorized to charge any other fees due under 37 C.F.R. § 1.16 or §1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

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By:

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RVB/FPD/cgb
Enclosures